

INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE
PROSECUTION OF THE SUBJECT APPLICATION

Applicants: T.L. Ritzdorf et al. Attorney Docket No.: WEYE118781
Int'l Application No.: PCT/US00/40985 Int'l Filing Date: September 25, 2000
U.S. Application No.: To be assigned
Filed: Concurrently Herewith
Title: PATTERN DEPENDENT SURFACE PROFILE EVOLUTION OF
ELECTROCHEMICALLY DEPOSITED METAL

U.S. PATENT DOCUMENTS

*Examiner Initials	Cite No.	Document No.	Kind Code	Date (mm/dd/yyyy)	Name
WL	U1	3,770,598	A	11/06/1973	Creutz
WL	U2	4,396,467	A	08/02/1983	Anthony
WL	U3	5,219,787	A	06/15/1993	Carey et al.
WL	U4	5,223,118	A	06/29/1993	Sonnenberg et al.
WL	U5	5,972,192	A	10/26/1999	Dubin et al.

Examiner

Date Considered

William Leader

9/23/2003

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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